



IFW
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of

Hiromi OTOMA

Group Art Unit: 2821

Application No.: 10/826,354

Examiner: C. TRAN

Filed: April 19, 2004

Docket No.: 119498

For: SURFACE EMITTING SEMICONDUCTOR LASER AND COMMUNICATION
SYSTEM USING THE SAME

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the October 18, 2005 Office Action, please consider the following:

Amendments to the Drawings include attached replacement sheets; and

Remarks.

02/23/2006 BABRAH1 00000037 10826354

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